

		Group Art Unit		2634				
	Fxaminer Name		Stephen CHIN					
Total Number of Pages in This Submission	Attorney Docket Number		742433-11					
ENCLOSURES (check all that apply)								
Fee Transmittal Form Fee Attached Amendment / Reply After Final Affidavits/declaration(s) Extension of Time Request Express Abandonment Request Information Disclosure Statement Certified Copy of Priority Document(s) Response to Missing Parts/ Incomplete Application Response to Missing Parts under 37 CFR 1.52 or 1.53	Assignm (for an / Drawing Declarat Licensin Petition Applicat Power o Change Termina Request	nent Papers Application) g(s) ion and Power of Attorney ng-related Papers to Convert to a Provisional		After Allowance Communication to Gro Appeal Communication to Board of Appeals and Interferences Appeal Communication to Group (Appeal Notice, Brief, Reply Brief) Proprietary Information Status Letter Application Data Sheet Request for Corrected Filing Receipt wi Enclosures A self-addressed prepaid postcard for acknowledging receipt Other Enclosure(s) (please identify below Request for Acknowledgement of Information Disclosure Statement Form 1449				
	Remarks The Commissioner is hereby required or credit any overpaymy above identified docket number.			v authorized to charge any additional fees nts to Deposit Account No. 19-2380 for the				
SIGNATU	IRE OF APPL	ICANT, ATTORNEY, C	R A	GENT				
Firm or Individual name Jeffrey L. Nixon Pea 401 9th St Suite 900	Costellia, Reabody LLP treet, N.W.	gistration No. 35,483						

Docket No. 740756-2616



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re P	atent Application of)	
	••) Confirmation No. 3323	
Shunp	pei YAMAZAKI et al.)	
_) Examiner: Khanh B. DUON	G
Serial	No. 10/446,187)	
	,) Group Art Unit: 2822	
Filed:	May 28, 2003) ·	
	•)	
For:	SEMICONDUCTOR DEVICE AND METHOD)	
	OF MANUFACTURING THE SAME)	

REQUEST FOR ACKNOWLEDGMENT OF INFORMATION DISCLOSURE STATEMENT

U.S. Patent and Trademark Office Customer Window, Mail Stop Amendment Randolph Building Alexandria, VA 22314

Sir:

A Corrected Information Disclosure Statement with Form PTO-1449 was filed in the above-identified patent application on September 3, 2003. Applicants have not yet received back from the Examiner a copy of the Form PTO-1449 initialed to acknowledge the fact that the Examiner has considered all cited disclosed information.

The Examiner is requested to initial and return to the undersigned a copy of the subject Form PTO-1449 listing the two references not yet considered.

Should there be any questions concerning this communication, please telephone the undersigned at the number set forth below.

Respectfully submitted,

Yeffrey L. Costellia

Registration No. 35,483

Nixon Peabody LLP 401 9th Street, N.W. Suite 900 Washington, DC 20004-2128 (202) 585-8000

Fax: (202) 585-8080

Date: January 26, 2005



PTO SB 08A (08-00) Approved for use through 10 31 2002. OMB 0651-0031

U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute for form 1449 \ PTO				Complete if Known							
				Application Number 10/446,187							
INFORMATION DISCLOSURE			-	Filing Date May 28, 2003							
STATEMENT BY APPLICANT				First Named Inventor				pei YAMAZAKI	et al.		
(use as many sheets as necessary)			_ -	Group Art Unit	-		2822				
				\vdash	Examiner Name			Khanh B. DUONG			
Sheet		1 of 1			Attorney Docket Number			†	740756-2616		
					740730-2010						
	I	<u> </u>		τ.δ.	S. PATENT DOCUMENT		Date of Publication of Cited		Pages, Columns, Lines, Where Relevant		
Examiner Initials	Cite No 1	U S Patent Document Number Kind Code ²			vame of Patentee or Applicant of Cited Document		ed			Passages or Relevant Fi	
				Code ²							
	-		(if known)								
									*		
				+ +							
	 						_				
	+			+ +			\dashv			-	
	 						-				
	1			FO	REI	GN PATENT DOCU	MENT	TS		<u></u>	
Examiner Initials*	Cite No Kind Code Office Number (if known)		Арр	Name of Patentee or Applicant of Cited Document MM-DD-YYYY		Where Relevant Passages or		T¢			
		Japan 10-249280			11/04/1998				Abstract		
	 		 								
	 		 								
	1									-	
			ОТН	ER PRIOR A	RT –	NON PATENT LITER	ATUR	E DOCUMEN	TS		
Examiner Initials*	Cite No.1										
	Inventors: Shunpei YAMAZAKI et al., "Semiconductor Device and Fabrication Method Thereof" Filed: July 6, 2000, Specification and Drawings for Application Serial No. 09/610,754 (w/Amendment of March 11, 2002).										
Examiner						Da	ite				
Signature	1					Co	ncider	ed			

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3) ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

¹ Unique citation designation number. ² Applicant is to place a check mark here if English language Translation is attached.